



Xie 3-4

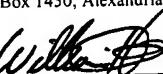
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Applicant(s): Z. Xie et al.
Case: 3-4
Serial No.: 10/623,983
Filing Date: July 21, 2003
Group: To Be Assigned
Examiner: To Be Assigned

Title: Shielding Structure for Use in a Metal-Oxide-Semiconductor Device

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature: 

Date: September 29, 2003

TRANSMITTAL OF FORMAL DRAWINGS

Mail Stop PGPUB Drawings
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attention: Official Draftsperson

Sir:

Applicants submit herewith five (5) sheets of formal drawings in the above-referenced application.

Respectfully submitted,



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Date: September 29, 2003